

Search Notes 	Application/Control No.	Applicant(s)/Patent under Reexamination
	10/660,106	MIURA, TAKAYOSHI
	Examiner	Art Unit
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)		
	DATE	EXMR
0A81 (ATTACHED)	6/3/05	X
INTERVIEW NAME (ATTACHED)	6/3/05	X
PUS	6/3/05	X
NPL (ATTACHED)	6/3/05	X